

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: S. MOTOWAKI, et al.
Serial No: 10/801,579
Filed: MARCH 17, 2004
Title: NANOPRINT EQUIPMENT AND METHOD OF MAKING FINE
STRUCTURE
Group AU: 1791
Examiner: Emmanuel S. Luk
Confirm. No : 2747

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF - FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 30, 2008

Sir:

In response to the Office Action mailed October 31, 2007, please amend the
above-identified application as listed in the following, and as set forth on the
following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.